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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Seishi MURAKAMI, et al.  
Serial No.: 10/584,642 Art Unit: Not Yet Assigned  
Filed: June 13, 2007 Examiner: Not Yet Assigned  
For: FORMATION OF TITANIUM NITRIDE FILM

**THIRD INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) and copies of the documents cited therein. The documents are cited in an accompanying Supplementary European Search Report issued in corresponding application EP 04 80 7927. As shown in the Search Report, documents AD and AH are counterparts.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

Further, Applicants certify under 37 C.F.R. 1.97(e)(1) that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,  
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